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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Toshifumi MORI**

Group Art Unit: **2818**

Serial No.: **10/694,359**

Examiner: **Thao P. Le**

Filed: **October 28, 2003**

Confirmation No.: **2556**

For: **METHOD FOR FABRICATING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **032068**

Customer Number: **38834**

**AMENDMENT UNDER 37 CFR § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

December 30, 2004

Sir:

In response to the Office Action dated October 4, 2004, Applicant amends the above-identified application as follows and submits the following remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.